

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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### Title of Invention

[SILICON OXIDE GAP-FILLING PROCESS]

Application Number :

10/605478

Confirmation Number:

First Named Applicant:

Hsiu-Chuan Chu

Attorney Docket Number:

12157-US-PA-X

Art Unit:

2824

Examiner:

C. WILSON

Search string:

( 5872058 or 6030881 or 6335261 ).pn

### US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
cdw	1	5872058	1999-02-16	Van Cleemput; Patrick A.		438692	H01C71302
cdw	2	6030881	2000-02-29	Papasouliotis; George D.		438424	H01L21762
cdw	3	6335261	2002-01-01	Natzle; Wesley		438435	H01L2100

### Signature

Examiner Name	Date
Christian Wilson	11/18/04